

# Electronic readout techniques

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With material from: B. Ketzer & M. Lupberger Lecture on *Physics of Particle Detectors* (2022/23) and B. Ketzer Lecture on *Advanced Gaseous Detectors* (2019)







- Part 1: A brief introduction
- Recap: Signal formation and Shockley-Ramo Theorem
- Electronic readout overview
- Discrete components
- Readout concepts
- Multi-channel readout and front-end chips

# Part 2: SRS demonstration

- The VMM front-end chip
- Overview on the RD51 Scalable Readout System
- SRS-VMM
- Live demo



# RECAP: SIGNAL FORMATION

Gaseous detector: Ionisation/excitation of gas atoms

- $\bullet$  lonisation separates e $\dot{\ }$  from A $^{\ast}$
- Electric field  $\Rightarrow$  further separation, drift, (amplification)
- Moving charges induce signals on field electrodes
- Possibility to use theses signals to infer
	- Where
	- When
	- How strong

the interaction with the detector medium was

NUCLEAR INSTRUMENTS AND METHODS 62 (1968) 262-268; © NORTH-HOLLAND PUBLISHING CO.

#### THE USE OF MULTIWIRE PROPORTIONAL COUNTERS TO SELECT AND LOCALIZE CHARGED PARTICLES

G. CHARPAK, R. BOUCLIER, T. BRESSANI, J. FAVIER and Č. ZUPANČIČ

CERN, Geneva, Switzerland

Received 27 February 1968





**Nobel Prize 1992 to Georges Charpak**

*for his invention and development of particle detectors, in particular the multiwire proportional chamber*



### Electronic readout techniques





Current I on given electrode i induced by moving charge

$$
I_i(t) = \frac{q}{U_i} \boldsymbol{\nabla} \phi_i \left[ \boldsymbol{x}_0(t) \right] \cdot \frac{\mathrm{d} \boldsymbol{x}_0(t)}{\mathrm{d} t} = - \frac{q}{U_i} \boldsymbol{E}_i \left[ \boldsymbol{x}_0(t) \right] \cdot \boldsymbol{v}(t)
$$

The current induced on a grounded electrode by a point charge q moving along a trajectory  $x_0(t)$  is  $I_i(t)$ , where  $E_i(x_0)$  is the electric field in the case where the charge  $q$  is removed, electrode i is set to voltage  $U_i$ , and all other electrodes are grounded.

- Convention:  $U_i = 1$
- $\bullet$   $\mathsf{E}_{\mathsf{j}}(\mathsf{x}_{\mathsf{0}})$ : Weighting field of electrode i at position  $\mathsf{x}_{\mathsf{0}}$
- $E_i \neq E_{\text{det},el}$ : Weighting field in general different to detector electric field
- ${\bf \hat e}_{_{\rm Ei}} \neq {\bf \hat e}_{\rm v}$ : Direction of weighting field different to charge trajectory



### What the electrode *sees*, example:



Important:

- Weighting field decoupled from charge movement
- Weighting field only given by detector electrode configuration
- Charge movement only given by E and B field and space charge



• Charge induced on electrode *i* by charge *q* moving from point 1 to 2 is

$$
Q_i = \int_{t_1}^{t_2} I_i(t) dt = -\frac{q}{U_i} \int_{t_1}^{t_2} E_i[x(t)] \dot{x}(t) dt = \frac{q}{U_i} [\phi_i(x_1) - \phi_i(x_2)]
$$

independent of actual path

- Once all charges have arrived at the electrodes, the total induced charge in a given electrode is equal to the charge that has been collected at this electrode
- In case there is an electrode enclosing all others, the sum of all induced currents is zero at any time Cathode





Practical application: Receipt to calculate signal current

- $\bullet$  Determine the weighting field  $\mathsf{E}^{}_{\mathsf{i}}(\mathsf{x}^{}_{\mathsf{o}})$  for electrode i by setting its potential to  $\cup_{\text{p}}(==1)$  and all other electrodes  $\text{j}$  to  $\cup_{\text{j}\neq \text{i}}=0$
- Determine the velocity and direction **v**(t) of the moving charge q, which can be usually inferred from the real field between electrodes (so determine the real field)
- Calculate  $i(t) = q/U$ <sub>i</sub>  $E_i(x_0)$  **v**(t)  $(U_i == 1)$

The space-time-relation **x**(t) gives the temporal evolution of the signal current i(t) at electrode i. Through integration from  $\bm{{\mathsf{t}}}_{_{\bm{0}}}$  to  $\bm{{\mathsf{t}}}$ , the induced signal charge  $Q_{s,i}(t)$  can can be calculated:

$$
Q_{S,i}(t) = -\int_{t_0}^t i_{S,i}(t') dt' = -q \int_{t_0}^t \vec{E}_{w,i} \, \vec{v} \, dt'
$$
  
= 
$$
-q \int_{\vec{r}(t_0)}^{\vec{r}(t)} -\nabla \phi_{w,i} \, d\vec{r} = q \left[ \phi_{w,i}(\vec{r}(t)) - \phi_{w,i}(\vec{r}(t_0)) \right].
$$



1. Weighting field:

- Set anode (readout electrode) to  $U_{1}=1 \Rightarrow \Phi_{1}=\Phi\left(x=0\right)=U_{1}=1$
- Set cathode (all other electrodes) to GND  $\Rightarrow$   $\Phi_2$   $\!=$   $\Phi$   $\!(x$   $\!=$   $\!d$   $)\!=$   $\!0$

$$
\Rightarrow \Phi_1(x) = \frac{U_1}{d}(d-x) = \frac{(d-x)}{d} \Rightarrow \vec{E}_1(\vec{x}_0) = E_1(x) = \frac{U_1}{d} = \frac{1}{d}
$$



2. Velocity and direction of charges **v**(t):

- $\bullet$  $\dot{x} =$ *dx dt*  $=$  $u = \mu E = \mu$ *U*1 *d*
- $\bullet$  $x(t=0)=x_0 \Rightarrow x(t)=\mu$ *U*1 *d*  $t + x_0$
- Ions and electrons contribute to signal! *uion*≪*ue*



3. Ramo:

• 
$$
I_1(t) = -\frac{q}{U_1} E_1[x(t)] \cdot \dot{x}(t) = -\frac{q}{U_1} \frac{U_1}{d} u = -\frac{q}{d} u
$$

 $\bullet$  lons and electrons contribute to signal:  $\ I_{1,e}(t)$  ,  $\ I_{1,ion}(t)$ 

• Take care on correct sign and charge for  $u_e$  and  $u_{ion}$ 



1<sup>st</sup> time interval: both charges drifting:  $t < t_e =$ *x*0  $u_e$ 

• 
$$
I_1(t) = I_{1,e}(t) + I_{1,ion}(t) = -\frac{q}{d}u_{ion} - \frac{-q}{d}(-u_e) = -\frac{q}{d}(u_{ion} + u_e)
$$
  
\n•  $Q_1(t) = \int_0^t I_1(t')dt' = -\frac{q}{d}(u_{ion} + u_e) \cdot t$ 

 $\theta$ 





2<sup>nd</sup> time interval: electron has arrived anode, ion drifts

 $t_e$  <  $t$  <  $t<sub>ion</sub>$  = *d*−*x*<sup>0</sup> *uion*

• 
$$
I_1(t) = I_{1,ion}(t) = -\frac{q}{d}u_{ion}
$$
  
\n•  $Q_1(t) = \int_{t_e}^{t_{ion}} I_1(t') dt' = -\frac{q}{d}(u_{ion} \cdot t + x_0)$ 





 $3<sup>rd</sup>$  $t$ <sup>rd</sup> time interval: electron and ion have arrived electrodes  $t > t$ 

$$
\cdot t_{ion} = \frac{d - x_0}{u_{ion}}
$$

• 
$$
I_1(t) = I_{\substack{t_{ion} \ t_{ion}}} (t) = I_{1,e}(t) = 0
$$
  
\n•  $Q_1(t) = \int_0^t I_1(t') dt' = -\frac{q}{d} (d+0) = -q$ 



Drawback of chamber discussed until now: Signal shape depends on  $x_{_0}$  (particle penetration point)

Remedy: grid at potential  $\mathsf{U}_{_{\mathrm{G}}}$  in front of anode with 0 <  $\mathsf{U}_{_{\mathrm{G}}}$  <  $\mathsf{U}_{_{\mathrm{cath}}}$ 



# SEGMENTED ELECTRODESUNIVERSITÄT BONN





### A detector is a current source

- delivers a current pulse independent of the load
- one can convert current into charge (integral) or voltage (via R or C)



[H. Spieler, Semiconductor detector systems, Oxford, 2005]



### Electronic readout techniques







[M Vandenbroucke, PhD thesis, TUM, 2012]



![](_page_21_Figure_1.jpeg)

[M Vandenbroucke, PhD thesis, TUM, 2012]

![](_page_22_Picture_0.jpeg)

![](_page_22_Figure_1.jpeg)

[M Vandenbroucke, PhD thesis, TUM, 2012]

![](_page_23_Picture_0.jpeg)

### Example analogue readout chain

![](_page_23_Figure_2.jpeg)

[H. Spieler, Semiconductor Detector Systems, Oxford 2005]

![](_page_24_Picture_0.jpeg)

![](_page_24_Figure_1.jpeg)

Purpose of pulse processing:

- 1. Acquire electrical signal from detector, typically a short current pulse
- 2. Optimise time response of the system to enhance:
- Minimum detectable signal (yes/no)  $\rightarrow$  S/N ratio
- Energy measurement  $\rightarrow$  Linearity
- Event rate  $\rightarrow$  Dead time/Throughput
- Time of arrival (timing)  $\rightarrow$  Time-invariance/Stability
- Insensitivity to sensor pulse shape  $\rightarrow$  Linearity
- 3. Digitize signal and store for subsequent analysis

# Layout of such a system heavily depends on application!

![](_page_25_Picture_0.jpeg)

![](_page_25_Figure_1.jpeg)

![](_page_26_Picture_0.jpeg)

Gaseous detectors signal: Sparks and large signals (Landau tail)  $\rightarrow$  protect electronics from high charge/current/power

![](_page_26_Figure_2.jpeg)

Micromegas:

- fast recovery from discharges needed, i.e. complete discharge of mesh to be avoided
- large bias resistor, input voltage approaches mesh voltage
- charge into amplifier limited by capacitor

GEM:

- diodes: ground every signal above minimum forward bias
- AC coupling to isolate from leakage currents of diodes
- potential defined through diodes

![](_page_27_Picture_0.jpeg)

![](_page_27_Figure_1.jpeg)

![](_page_28_Picture_0.jpeg)

Basic component: operational amplifier

![](_page_28_Figure_2.jpeg)

Differential voltage amplification (gain):

 $U_{\text{out}} = A_{\text{D}}(U_{\text{P}} - U_{\text{N}}) = A_{\text{D}}U_{\text{D}}$ (open-loop gain, i.e. without feedback)typ.  $10^4 < A_D < 10^6$ 

![](_page_29_Picture_0.jpeg)

### Transmission characteristics

![](_page_29_Figure_2.jpeg)

![](_page_30_Picture_0.jpeg)

# Voltage-sensitive amplifier<br>
Equivalent circuit

- voltage generator has zero source resistance
- actual source resistance represented by  $R_S$
- designed to minimize loss of signal voltage at amplifier input
- signal voltage at the amplifier input

$$
v_i = \frac{R_i}{R_S + R_i} v_S
$$

![](_page_30_Figure_8.jpeg)

- for  $R_i \gg R_s \Rightarrow v_i \approx v_s$ , i.e. amplifier input resistance (or impedance) must be large compared to source resistance (impedance)
- for voltage output: output resistance small compared to input of the following stage

![](_page_31_Picture_0.jpeg)

Capacitive sources Until now: resistive sources Now: capacitive sources

- sensor signal: current pulse of  $\bullet$ magnitude  $i_s$  and duration  $t_c$
- signal charge:  $Q_s = \int i_s(t) dt \approx i_s t_c$
- with voltage gain  $A_{\nu}$  the output voltage is  $v_0 = A_v v_s$

#### Equivalent circuit

![](_page_31_Figure_6.jpeg)

Whether amplifier operates in current or voltage mode depends on  $t_c$  and  $R_i C_d$ 

- $R_i C_d \ll t_c$ : sensor capacitance discharges rapidly  $\Rightarrow v_0 \propto i_s(t)$ (instantaneous current), i.e. system operates in current mode
- $R_i C_d \gg t_c$ : detector capacitance discharges slowly  $\Rightarrow$  signal current is 2. integrated on sensor capacitance before discharging through input resistance  $\Rightarrow v_0 = V_0 \exp\left(-\frac{t}{R_i C_d}\right)$ ,  $V_0 = Q_S/C_d \propto \int i_S(t) dt$ , i.e. system operates in voltage mode

![](_page_32_Picture_0.jpeg)

# Current-sensitive amplifier<br>
Equivalent circuit

- signal source represented by current generator with infinite source resistance
- finite source resistance represented by shunt resistance  $i_S$
- fraction of current flowing into amplifier

$$
i_i = \frac{R_S}{R_S + R_i} i_S
$$

![](_page_32_Figure_7.jpeg)

- For  $R_i \ll R_s \Rightarrow i_i \approx i_s$ , i.e. amplifier input resistance (or impedance) must be small compared to source resistance (impedance)
- for current drive: output resistance high compared to input of the following stage

![](_page_33_Picture_0.jpeg)

# Feedback

Caveat:

• Amplification depends on transistor characteristics (e.g. gain, resistance) ⇒ can vary from device to device, depends on temperature T!

Dependence of currents on T (diode)  $\Rightarrow$  working point may be unstable

#### Remedy: negative feedback  $\Rightarrow$  couple output into input so that part of input is compensated

- Improves stability
- **Improves linearity**
- Improves bandwidth (but gain  $*$  bandwidth = const.)
- Make system predictable

![](_page_34_Picture_0.jpeg)

# Charge-sensitive amplifier

Integrator:

- inverting voltage amplifier with high input resistance
- feedback capacitor  $C_f$  $\bullet$

Rule: No current into inverting input

![](_page_34_Figure_6.jpeg)

 $\Rightarrow$  U<sub>out</sub> is independent of C<sub>d</sub>!

![](_page_34_Figure_8.jpeg)

Note:

• Potential difference over  $C_f$ :

$$
U_f = U_{in} - U_{out} = U_{in}(A_D + 1) = \frac{Q_f}{C_f}
$$

• Charge on  $C_f$ :  $Q_f = Q_{in}$ 

![](_page_35_Picture_0.jpeg)

# Charge-sensitive amplifier  $C_{d} \rightleftharpoons U_{in}$

Effective input capacitance:

 $\Rightarrow U_{\text{in}}(1+A_D)=$ 

$$
Z_{\text{in}} = \frac{1}{i \omega C_{\text{in}}} \qquad C_{\text{in}} = \frac{Q_{\text{in}}}{U_{\text{in}}}
$$

![](_page_35_Figure_4.jpeg)

$$
Z_{in} = \frac{1}{i \omega C_{in}} \qquad C_{in} = \frac{Q_{in}}{U} \qquad U_{out} = A_D (U_P - U_N) = -A_D U_{in}
$$

$$
U_{\text{in}} = \frac{Q_f}{C_f} + U_{\text{out}} = \frac{Q_{\text{in}}}{C_f} - A_D U_{\text{in}}
$$
  

$$
\rightarrow U_{\text{in}} (1 + A) - Q_{\text{in}} \rightarrow Q_{\text{in}} - C - C A
$$

⇒

 $U_{\rm in}$ 

Dynamic input capacitance

$$
\Rightarrow \text{total impedance} \ \ Z_{\text{in}} = \frac{1}{i \omega C_{\text{in}}} \ \ \text{is low!}
$$

*Cf*

 $\equiv C_{\text{in}} = C_f (A_D + 1)$ 

![](_page_36_Picture_0.jpeg)

# Charge-sensitive amplifier

Charge amplification:

![](_page_36_Figure_3.jpeg)

$$
A_Q = \frac{U_{out}}{Q_{in}} = \frac{-A_d U_{in}}{U_{in}} C_{in} = -\frac{A_D}{C_{in}} = -\frac{A_D}{C_f (A_D + 1)} \approx -\frac{1}{C_f}
$$
  
A part of charge Q generated in detector stays on C<sub>a</sub>!

A part of charge Q generated in detector stays on C<sub>d</sub>!  
\n
$$
Q=Q_D+Q_f=C_D U_{in}+C_f (U_{in}-U_{out})=U_{in}(C_D+C_{in})
$$

$$
C_{\text{in}} = C_f (A_D + 1) < \infty
$$
  
\n
$$
\Rightarrow Q_{\text{rest}} = U_{\text{in}} C_D = Q \frac{C_D}{C_D + C_{\text{in}}}
$$

Example:  $A_{D} = 1000$ ,  $C_{f} = 1$  pF,  $C_{D} = 10$  pF  $\Rightarrow$  Signal charge Q<sub>s</sub> = Q – R<sub>rest</sub> = 99 % Q (C<sub>p</sub> = 10 pF) | 67 % Q (C<sub>p</sub> = 500 pF)  $Q_{\rm rest} \Rightarrow$  capacitive cross-talk between strips or pixels Ideally:  $Q_{rest} = 0 \Rightarrow C_{in} >> C_{D}$ !

![](_page_37_Figure_0.jpeg)

![](_page_38_Picture_0.jpeg)

### Use known input charge:

- add test capacitor  $C_T$  to input  $\bullet$
- inject well-defined charge via voltage  $\bullet$ step  $\Delta V$
- if  $C_i \gg C_T$ , the voltage step  $\Delta V$  at the  $\bullet$ test input is applied almost completely across the test capacitance  $\Rightarrow$  injection of charge  $C_T \Delta V$  into the input
- More precisely:  $\bullet$

$$
Q_T = \frac{C_T}{1 + \frac{C_T}{C_i + C_d}} \cdot \Delta V \approx C_T \left(1 - \frac{C_T}{C_i + C_d}\right) \Delta V
$$

⇒ calibrate system with detector connected for best accuracy!

![](_page_38_Figure_8.jpeg)

![](_page_39_Picture_0.jpeg)

![](_page_39_Figure_1.jpeg)

![](_page_40_Picture_0.jpeg)

Further pulse shaping necessary for

- Reducing pile-up
- Increasing signal to noise ratio
- Two conflicting objectives:

![](_page_40_Figure_5.jpeg)

• Limit bandwidth to match measurement time: too large a bandwidth will increase the noise without increasing the signal

![](_page_40_Figure_7.jpeg)

• Constrain pulse width so that successive signal pulses can be measured without overlap (pile-up): increases signal rate, but also electronic noise

![](_page_40_Figure_9.jpeg)

![](_page_41_Picture_0.jpeg)

# Pulse shaping filters

• High pass - differentiator

![](_page_41_Figure_3.jpeg)

• Low pass - integrator

![](_page_41_Figure_5.jpeg)

![](_page_41_Figure_6.jpeg)

![](_page_41_Figure_7.jpeg)

![](_page_42_Picture_0.jpeg)

### CR-RC shapter

[H. Spieler, Semiconductor Detector Systems, Oxford Univ. Press, 2005]

![](_page_42_Figure_3.jpeg)

 $\rightarrow$  More symmetric pulse shapes: CR-nRC shaper

![](_page_42_Figure_5.jpeg)

![](_page_43_Picture_0.jpeg)

![](_page_43_Figure_1.jpeg)

ideal

real

![](_page_44_Picture_0.jpeg)

# Sample & hold

- If signal shape and arrival time are ~ known
- ⇒ spread signal on inputs • Successively close/open
- switches  $S_{\alpha i}$  and  $S_{\beta i}$  (sample) ⇒store analogue signals at different times (hold)
- Serially read path I with Analogue to Digital (ADC) converter

![](_page_44_Figure_6.jpeg)

![](_page_45_Picture_0.jpeg)

## Flash ADC

- parallel A/D converter  $\Rightarrow$ 2<sup>n</sup>-1 comparators for n bits
- Pro:
	- conversion time very short:  $\sim$  1 ns  $\Rightarrow$  high-bandwidth applications:  $\sim$ Gsps
- Con:
	- accuracy limited by number of comparators typ. 8 bit
	- high power consumption
	- differential non-linearity  $-1\%$

![](_page_45_Figure_9.jpeg)

![](_page_46_Picture_0.jpeg)

# Wilkinson ADC

- stretching of input signal
- charging of a capacitor by input signal
- discharging of capacitor at constant rate (current source)
- counter determines the number of clock pulses until voltage on capacitor reaches baseline
	- + excellent differential linearity
	- slow:
		- conversion time =  $n \cdot T_{C-K}$
		- $n =$  channel  $\# \propto$  pulse height
		- $\approx$  40 $\mu$ s for 100MHz and 12 bit

![](_page_46_Figure_11.jpeg)

![](_page_47_Picture_0.jpeg)

# MULTI-CHANNEL READOUT

# Gaseous detector readout

- Strips (1D, **2D**, X-V-U)
- Pads
- Pixel

![](_page_47_Picture_6.jpeg)

![](_page_47_Picture_7.jpeg)

GEM<sub>1</sub>  $E_{T1}$ GEM 2  $E_{T2}$ GEM<sub>3</sub> .<br>T3 GEM 4 pad plane

![](_page_47_Picture_9.jpeg)

Fraunhofer IZM

Stage at T = 70.1

Chamber = 7.23e-004 Pa

 $3C3X$ 

 $WD = 18$  mm

Signal A = SE2

EHT = 20.00 kV

 $\frac{20 \mu m}{2}$ 

![](_page_47_Picture_12.jpeg)

![](_page_48_Picture_0.jpeg)

# MULTI-CHANNEL READOUT

Gaseous detector readout

- High rates and large #channels  $\rightarrow$  little space  $\Rightarrow$  discrete components  $\rightarrow$  integrated circuit (IC)
- Application Specific Integrated Circuits (ASIC)
- Example of fully integrated gaseous detector: GridPix = Timepix(3)ASIC + Micromegas

![](_page_48_Picture_6.jpeg)

![](_page_48_Picture_7.jpeg)

![](_page_48_Figure_8.jpeg)

![](_page_48_Figure_9.jpeg)

30.11.2023 Michael Lupberger 49

![](_page_49_Picture_0.jpeg)

# MULTI-CHANNEL READOUT

# Gaseous detector readout

- High rates and large #channels  $\rightarrow$  little space  $\Rightarrow$  discrete components  $\rightarrow$  integrated circuit (IC)
- Application Specific Integrated Circuits (ASIC)
- ASIC connected to strips/pads

Example: VMM3a

![](_page_49_Picture_7.jpeg)

![](_page_49_Picture_8.jpeg)

![](_page_49_Figure_9.jpeg)